

**RECEIVED
CENTRAL FAX CENTER**

MAR 12 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**OFFICIAL**

Applicant(s): Jeng-Yang Pan

Application No.: 10/013,089 (CONF 1424)

Filed: 12/7/2001

Title: Semiconductor wafer tray positioning

Attorney Docket No.: 67,200-627

Group Art Unit:
2813Examiner:
Jennifer M. DolanCommissioner for Patents
Alexandria, VA 22313Certificate of Facsimile Transmission

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Patent Office via facsimile no. (703) 872 9319 on the date shown below.

Date:

3/12/04
Kathy DixonREQUEST FOR RECONSIDERATION

Dear Sir:

In response to a final Office Action dated Jan. 13, 2004, please enter the following amendments and consider the following remarks.